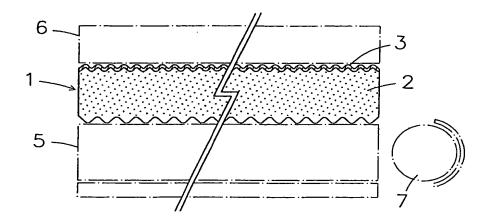
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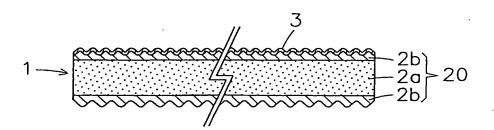
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Fìg. 1 第<del>1</del> 図



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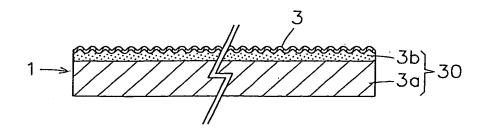
Fig. 2 第<del>2</del> 図



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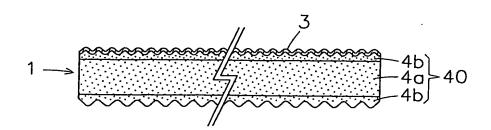
Fig. 3 第3 図



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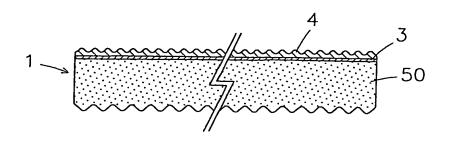
Fig. 4 第 4 図



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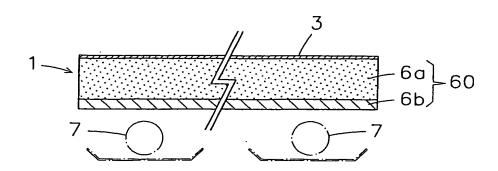
Fig. 5 第5回



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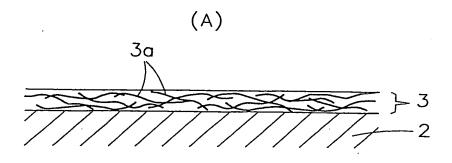
Fig. 6 第 6 図

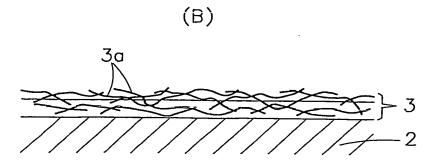


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Fig. 7 第 7 図





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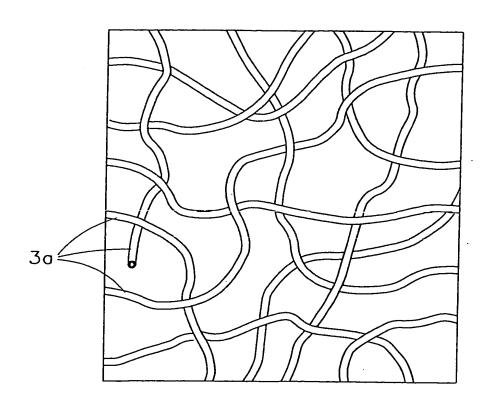
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Fig. 8 第8図



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Fig. 9 <del>第9</del> 図

